



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUBA

Group Art Unit: 2851

Application No.: 09/691/639

Docket No.: 105193.01

Filed: October 27,12000

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO DEVICE

USING THE EXPOSURE APPARATUS

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

Respectfully submitted,

James A. Oliff Registration No. 27,075

Mario A. Costantino Registration No. 33,565 RECEIVED

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Date: August 9, 2001

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